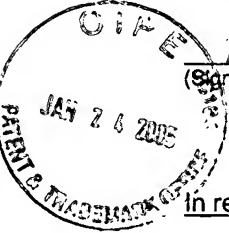


I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents and Trademarks, P.O. Box 1450, ALEXANDRIA, VA 22313-1450, on January 21, 2005. The applicant and/or attorney requests the date of deposit as the filing date. Depositor: by Nicole Barrese

  
Nicole Barrese  
(Signature & date)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of \_\_\_\_\_: January 21, 2005

Chen, et al.:

Serial No.: 10/604,058

Filed: 6/24/03

Group Art Unit: 1762

Confirmation No.: 1057

Examiner: Jeffrey Olsen

International Business Machines Corporation

2070 Route 52

Hopewell Junction, NY 12533

**TITLE: PLASMA PROCESSING MATERIAL RECLAMATION AND REUSE**

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure set forth in 37 C.F.R. 1.56, and further pursuant to the provisions of 37 C.F.R. 1.97 and 1.98, applicants hereby respectfully submit copies of the publications as listed on Form PTO-1449, attached hereto.

In citing these documents, no representation is made nor intended as to the pertinency or non-pertinency of the art, that better art than that listed is not available, or that other art is not applicable.

No fee is believed to be due for this submission. If any fees are required, however, the Commissioner is hereby authorized to charge such fees to Deposit Account No. 09-0458.

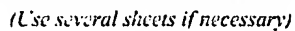
Respectfully submitted,  
Chen, et al.

By

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